

Active Optics and Wavefront Control

 National Aeronautics and Space
Administration
Jet Propulsion Laboratory
California Institute of Technology

Active Hybrid Mirrors



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Active Optics for a 16-Meter Advanced Technology Large Aperture Space Telescope (ATLAS-T16)

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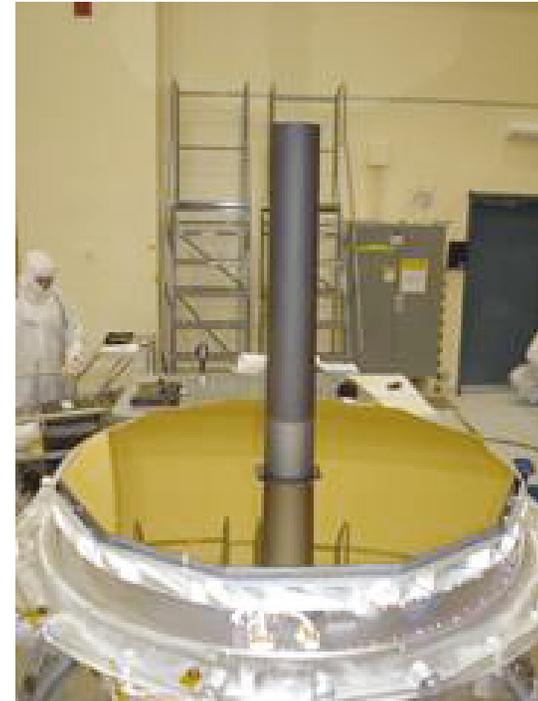
June 28, 2008

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David Redding

Active Hybrid Mirrors (AHM)

- **Active Hybrid Mirrors (AHM) is this new paradigm for making affordable meter class large optics**
 - A combination of precision replication and active control
- **AHM's are the combination of three distinct technologies**
 - Facesheet: Nanolaminate foil (LLNL)
 - Substrate/Figure Control: Precision actuation integrated in silicon carbide (NG/Xinetics, Inc)
 - Wave Front Sensing and Control: Phase Retrieval Camera and WFC algorithms (JPL)



AHM Hybrid Mirrors

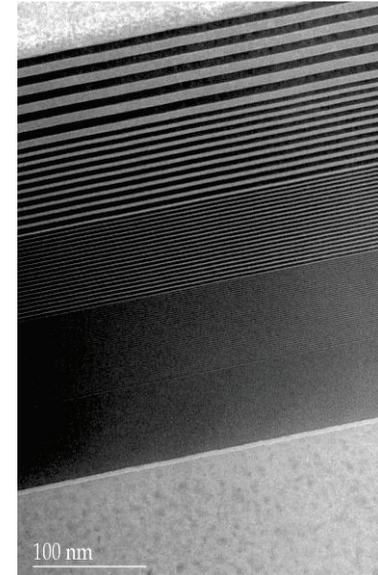
Precision Replicated Nanolaminate Mirrors

▪ Nanolaminates Material Development

- Nanolaminate materials are multi-layer metallic foils grown by sputter deposition with atomic-scale control
- Very thin, lightweight, flexible but stiff structures with low scatter, optically precise surface finish
- Current material systems have tailorable low thermal expansion and low residual thermal stress to match AHM SiC substrates thermal expansion
- Fabrication time is independent of diameter, typically 3 to 4 days dependent on thickness

▪ Current Nanolaminate Mirror Production Capability at LLNL

- 1.2 m Very Large Optical Coating (VLOC) nanolaminate processing facility
 - Four 1.4 m long magnetron sputtering guns
 - Mandrel table linear motion and rotation computer controlled to provide uniform deposition
- Precision Cleaning Facility capable of cleaning 1.5 m master mandrels to semiconductor cleanliness levels



TEM cross section of a
ZrC/Si nanolaminate



Advanced Silicon Carbide Substrates

- **AHM utilizes state of the art silicon carbide for advanced structures and electrostrictive actuators**
 - Nano-structured silicon carbide structures that are ultra-lightweight, have exceptional dimensional stability and consistent high structural properties
 - High Stability PMN electrostrictive actuators that provide nanometer level of control authority
 - Robotic bonding of Hybrid Mirrors that ensure high quality, reproducible bonding processes that are scalable to meter class optics



85 cm Silicon Carbide Substrates



Ultra Stable PMN Actuators

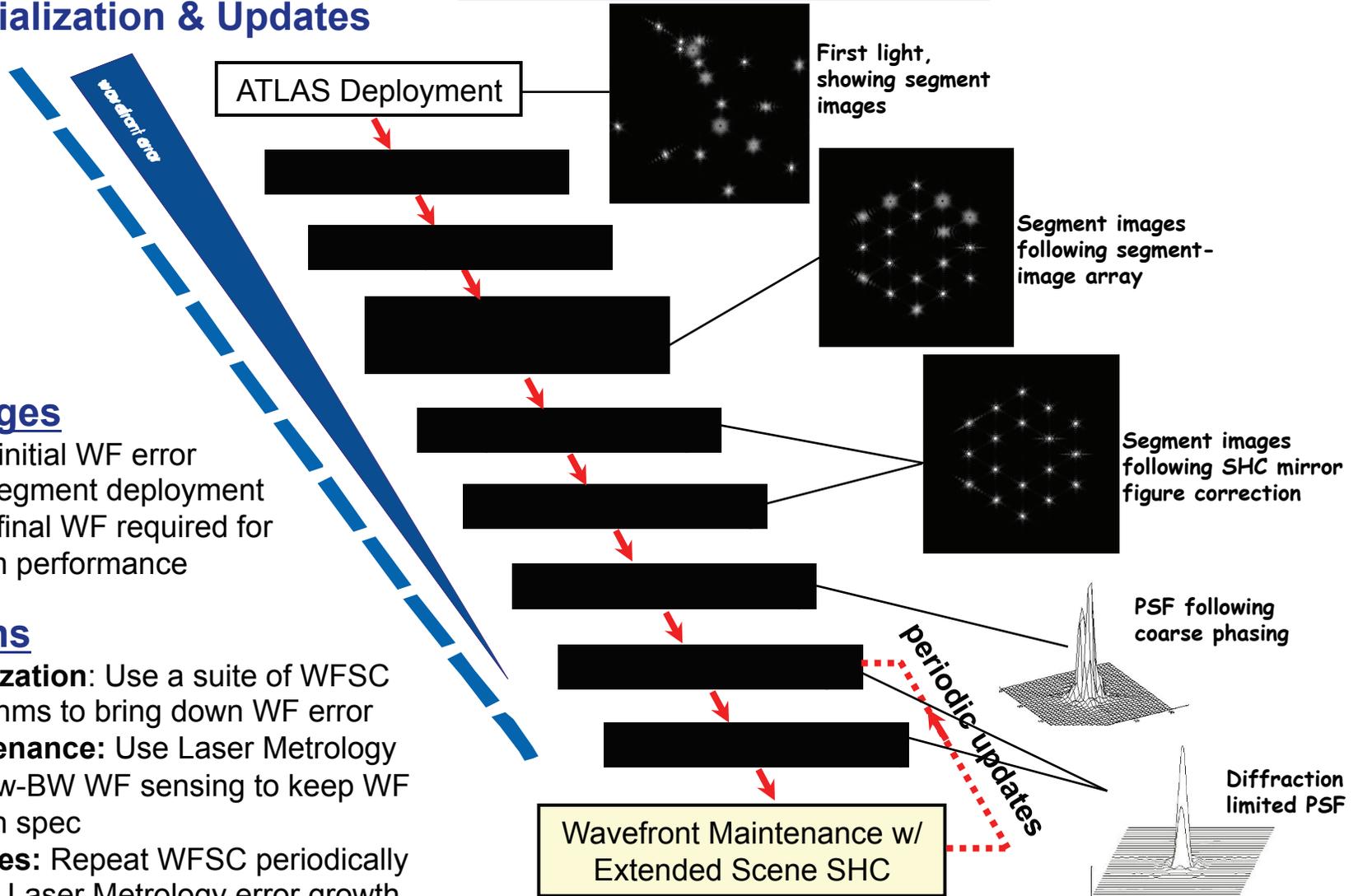


Robotic Bonding

WF Sensing and Control

Chart borrowed from JWST – Scott Acton/Ball

WF Initialization & Updates



Challenges

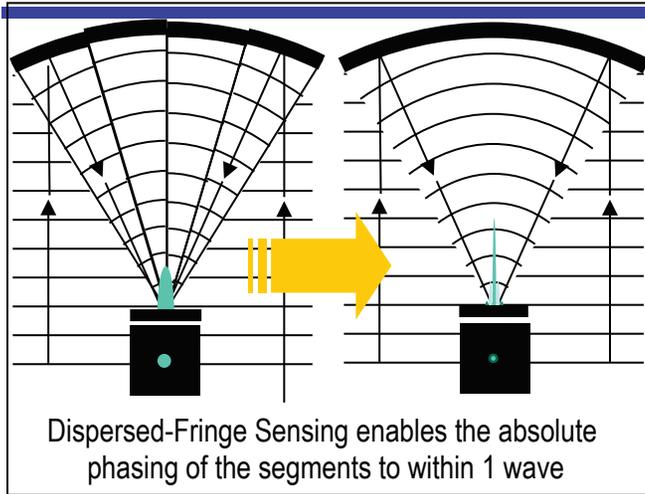
- Large initial WF error after segment deployment
- Small final WF required for system performance

Solutions

- **Initialization:** Use a suite of WFSC algorithms to bring down WF error
- **Maintenance:** Use Laser Metrology and low-BW WF sensing to keep WF error in spec
- **Updates:** Repeat WFSC periodically to limit Laser Metrology error growth

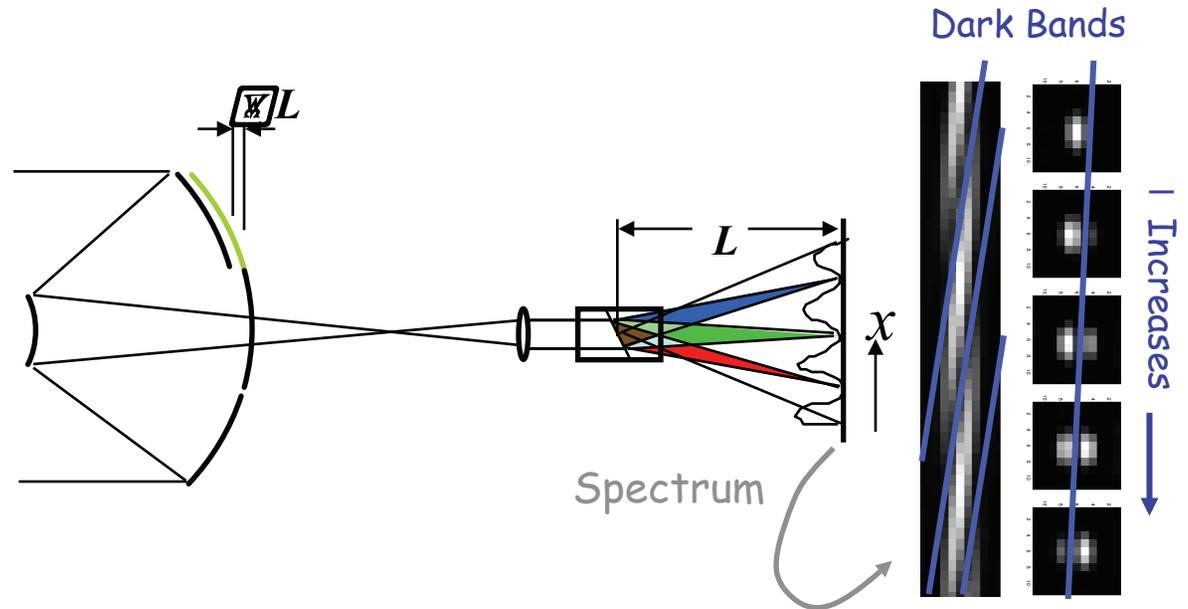
WF Maintenance

Coarse Phasing: Dispersed Fringe Sensing



- DFS uses segment steering to select segment combinations for control
- “Dispersed Hartmann Sensing” (DHS) is DFS with prisms that select edge patches only
 - JWST approach

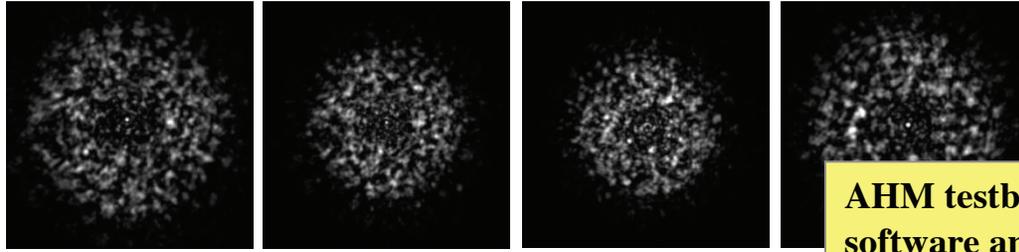
- Dispersed-Fringe Sensing (DFS) uses a dispersive element (a grism) in an imaging camera to spread spot images into linear spectra



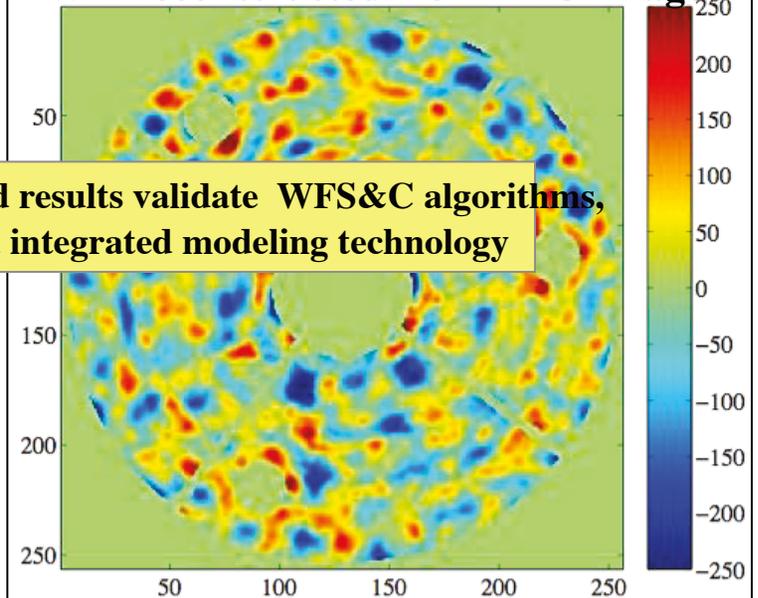
- Wavelength variation along the spectrum modulates fixed path differences between segments to create interference fringes:
 - Bright peak where l is coherent with dL
 - Dark null where l is out of phase with dL
- Period of fringe gives absolute piston displacement
- Slope of dark bands gives the sign

Wavefront Sensing and Control

Defocussed PRC Images



WF Reconstructed from PRC Images

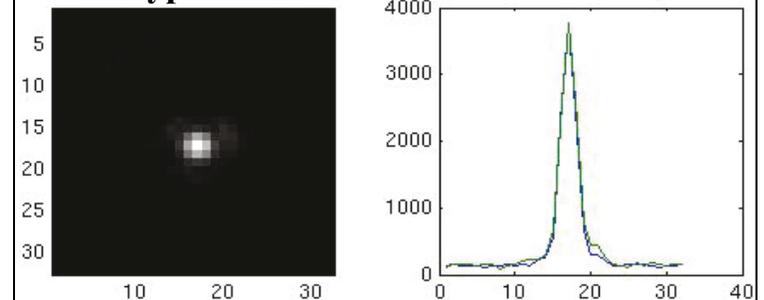


AHM testbed results validate WFS&C algorithms, software and integrated modeling technology

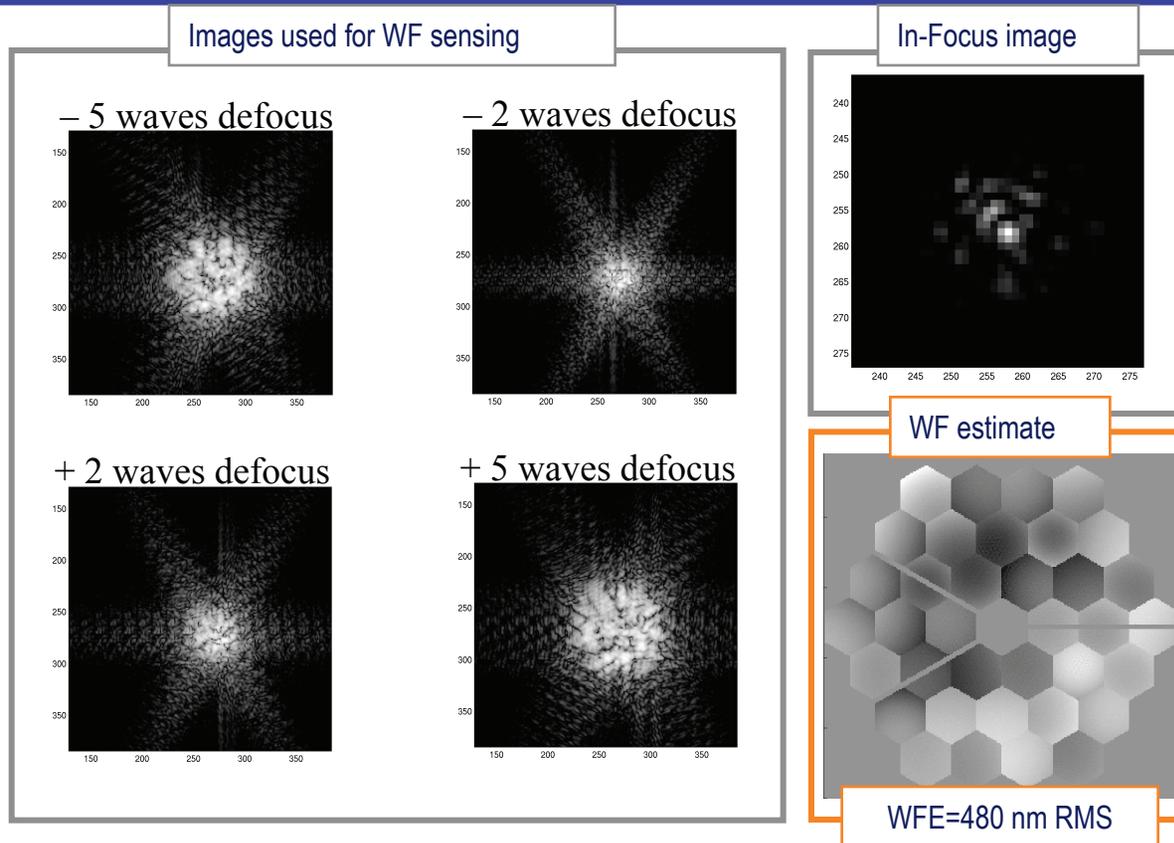
- **AHM uses WFS&C technologies developed by JPL for NASA and other agencies**
 - Applied on JWST/NGST testbeds and pathfinder optics, Spitzer/SIRTF, TPF/High Contrast Imaging Testbed, Palomar Observatory Hale Telescope, and many others
- **Proven JPL technologies also support follow-on segmented mirror telescopes**
 - Segmented Mirror WF Control
 - Shack-Hartmann WF Sensing
 - Phase Retrieval WF Sensing
 - Precision Metrology
 - Integrated Modeling

Double-pass WF = 83 nm (RMS)
Equivalent single-pass WFE = 42 nm (RMS)

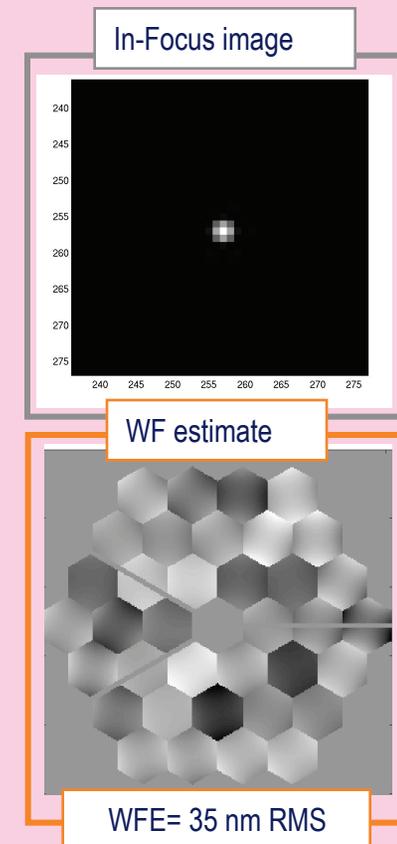
Typical Double-Pass In-Focus PSF



Example: Fine-Phasing 36-Hex PM

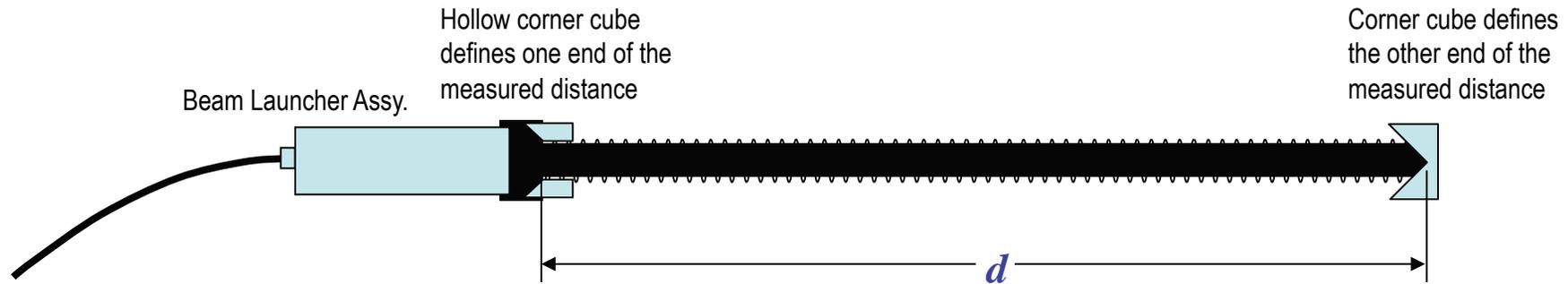


- Post-control WF meets 150 nm objective



- Fine Phasing uses MGS Phase Retrieval to estimate WF
- WF control is applied using segment RB and RoC actuators

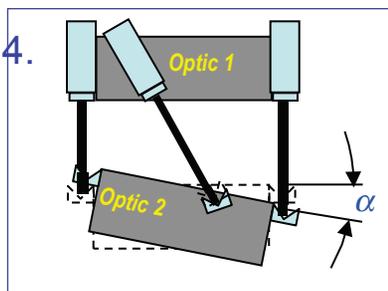
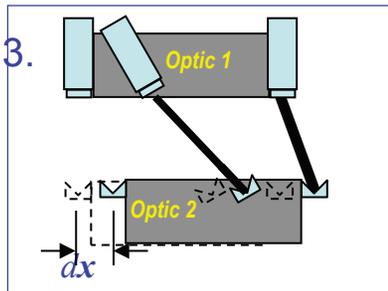
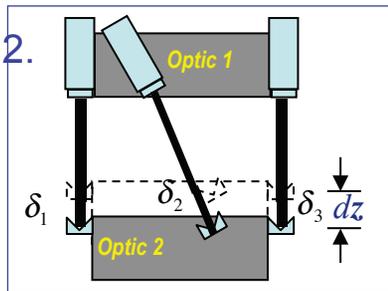
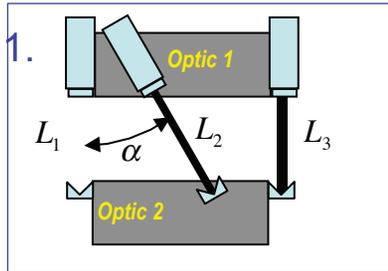
A Laser Distance Gauge



- **At the conceptual level, a Laser Distance Gauge (LDG) is a “yardstick,” with “inchmarks” provided by the interference fringes of the laser beam**
 - Changes in the distance d between the Beam Launcher (BL) and the Corner Cube (CC) are measured as phase shifts between input and output beams
 - Intrinsic accuracy is better than 1 nm
 - We “count fringes” to track large changes in d
 - A 2-color mode provides a large “absolute mode”
- **We can keep the BL and CC the same distance apart, by position feedback control of the BL and/or CC to keep d constant**
 - LDG runs at high BW (nominally 1 kHz)

▪ **A SIM Mission-derived technology application funded by JPL R&TD**

A 2-Dimensional LT Example



- This 2-D example illustrates use of LDG measurements to estimate rotational as well as translational DOFs between bodies

1. Nominal geometry. There are 3 relative DOFs – x and z translation, and θ rotation

2. Changes in LDG measurements due to a z translation:

$$\delta_1 = dz; \quad \delta_2 = \cos(\alpha)dz; \quad \delta_3 = dz;$$

3. Changes in LDG measurements due to an x translation:

$$\delta_1 = 0; \quad \delta_2 = \sin(\alpha)dx; \quad \delta_3 = 0;$$

4. Changes in LDG measurements due to a θ rotation:

$$\delta_1 = r_1\theta; \quad \delta_2 = r_2 \sin(\alpha)\theta; \quad \delta_3 = r_3\theta;$$

- The measurement in matrix form

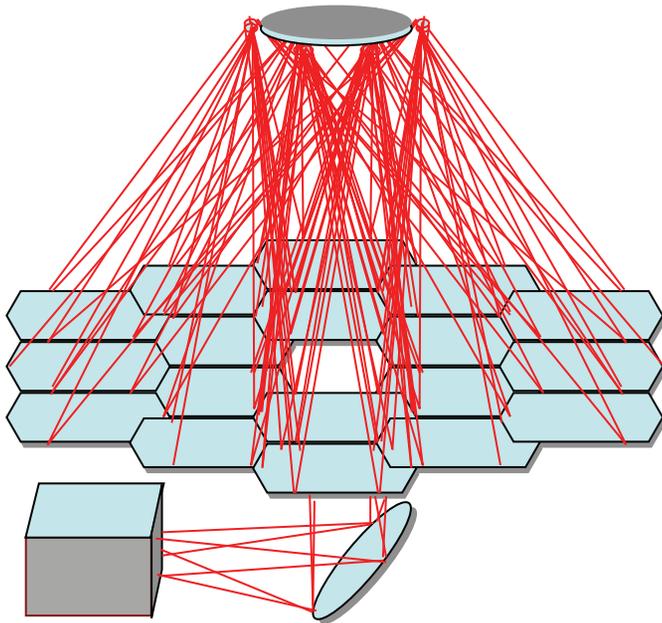
$$\delta = \begin{bmatrix} \delta_1 \\ \delta_2 \\ \delta_3 \end{bmatrix} = \begin{bmatrix} 0 & 1 & r_1 \\ \sin(\alpha) & \cos(\alpha) & r_2 \sin(\alpha) \\ 0 & 1 & r_3 \end{bmatrix} \begin{bmatrix} dx \\ dz \\ \theta \end{bmatrix} = Cx$$

- A simple state estimator

$$x = C^{-1} \delta$$

- Feedback control based on the δ measurements can keep the truss aligned

The Full 3-Dimensional Laser Truss



- **The same approach is extended for the full 3-D LT**
 - 6 LDGs per segment measure all relative RB DOFs in the entire OTA
 - All PM segments, the SM, FF, TM and OBA
 - The IRS is attached to the OBA, providing measurements of 6 more absolute DOFs wrt inertial space
- **Same measurement equation:** $\delta = Cx$
 - Sensitivities computed from model kinematics
- **Measurement is invertible:** $x = C^{-1}\delta$ is full rank
- ***Optical State Estimator* uses a Kalman Filter to estimate the RB state**
 - Balances measurement vs. prior knowledge for optimal estimate
 - Predicts WF and Boresight from state estimate
- **Feedback control using RB actuators and optimal control laws keeps performance in spec**
 - Integrated model will be used to evaluate performance